

Reply Under 37 C.F.R. § 1.116 - Expedited Procedure - Technology Center 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jeffrey S. REITER

Application No.: 10/810,638

Customer No.: 49745

Confirmation No.: 9583

Filed: March 29, 2004

Group Art Unit: 1795

Examiner: McDonald, Rodney Glenn

Title: ELECTRICAL BIASING OF GAS INTRODUCTION MEANS OF PLASMA
APPARATUS

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

These amendment and remarks are being filed in response to the final Office Action
dated March 3, 2008, pursuant to 37 C.F.R. § 1.116.

Amendment to the Claims begin on page 2.

Remarks begin on page 6.